35.C14386

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

SEIJI MISHIMA ET AL.

Continuation of International
Application No.: PCT/JP00/01024:

Filed: Herewith

For: METHOD OF MANUFACTURING
ELECTRONIC DEVICE,
ELECTRON SOURCE SUBSTRATE,
AND IMAGE FORMING
APPARATUS, AND APPARATUS
FOR MANUFACTURING
ELECTRONIC DEVICE AND

October 23, 2000

Examiner: Unassigned

Group Art Unit: Unassigned

Assistant Commissioner for Patents Washington, D.C. 20231

ELECTRON SOURCE SUBSTRATE:

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Immediately after the title, please insert the following:

--This application is a continuation of
International Application No. PCT/JP00/01024, filed February
23, 2000, which claims the benefit of Japanese Patent